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I/TW

Docket No.: R2180.0159/P159  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Kazunari Kimino

Application No.: 10/609,634

Confirmation No.: 4954

Filed: July 1, 2003

Art Unit: 1734

For: APPARATUS AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR  
DEVICE

Examiner: George R. Koch

DO NOT ENTER  
GRK  
6/22/06

**AMENDMENT AFTER FINAL**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Final Office Action dated March 15, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims begin on page 2 of this paper.**

**Remarks begin on page 9 of this paper.**